

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Chung et al.	Confirmation No.: 4723
Serial No.: 10/823,352	Group Art Unit: 2812
Filed: April 13, 2004	Examiner: Scott B. Geyer
For: METHODS OF FORMING CAPACITORS OF SEMICONDUCTOR DEVICES INCLUDING SILICON-GERMANIUM AND METALLIC ELECTRODES	

September 7, 2006

Mail Stop Issue Fee  
Commissioner for Patents  
Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER ALLOWANCE PURSUANT TO 37 CFR 1.312**

Sir:

This Amendment After Allowance is responsive to the "Notice of Allowance and Fee(s) Due" mailed August 25, 2006.

It is not believed that an extension of time and/or additional fee(s)-including fees for net addition of claims-are required, beyond those that may otherwise be provided for in documents accompanying this paper. In the event, however, that an extension of time is necessary to allow consideration of this paper, such an extension is hereby petitioned under 37 C.F.R. §1.136(a). Any additional fees believed to be due in connection with this paper may be charged to our Deposit Account No. 50-0220.

**Amendments** to the title begin on Page 2 of this paper.

**Remarks** begin on Page 3 of this paper.